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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Toshinori Ota et al.

Serial No.: 10/555,855

Filed: November 7, 2005

New York, New York

Date: August 29, 2006

Group Art Unit: 1753

Examiner: ---

For: THERMOELECTRIC SEMICONDUCTOR MATERIAL, THERMOELECTRIC SEMICONDUCTOR ELEMENT USING THERMOELECTRIC SEMICONDUCTOR MATERIAL, THERMOELECTRIC MODULE USING THERMOELECTRIC SEMICONDUCTOR ELEMENT AND MANUFACTURING METHOD FOR SAME

Commissioner for Patents

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SUBMISSION OF INFORMATION DISCLOSURE STATEMENT

Sir:

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Robert C. Faber

Name of applicant, assignee or
Registered Representative

Signature

August 29, 2006

Date of Signature

Respectfully submitted,

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Enclosures



APPLICANT'S ART CITATION (Use several sheets if necessary)		Application 10/555,855		OFGS File No. P/2850-120		
		Applicant Toshinori OTA et al.				
		Filing Date November 7, 2005		Group Art Unit 1753		
U.S. PATENT DOCUMENTS (not submitted for applications filed after 6/30/03)						
Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate
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						Yes
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Hiroshi Kato and Keiji Yoshikawa, "Elastic Constants of Al-Cu Alloys Containing Columnar Crystals" April 1981, Journal of the Society of Materials Science, Volume 30, No 331.

Examiner

Date Considered

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.